

Notice of References Cited	Application/Control No. 10/713,671	Applicant(s)/Patent Under Reexamination SIMONIAN ET AL.	
	Examiner Brian K. Talbot	Art Unit 1762	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2005/0109277	05-2005	Kobrin et al.	118/715
	B	US-6,902,947	06-2005	Chinn et al.	438/48
	C	US-6,537,380	03-2003	Zazerra et al.	134/2
	D	US-6,576,489	06-2003	Leung et al.	438/52
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Ashurst et al., "Wafer level anti-stiction coating on MEMS", Elsevier Science, 5/6/03 pp. 1-26
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.